



P/4303-34

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Valentin CHITIC et al.

Date: July 12, 2004

Serial No.: 10/780,334

Group Art Unit: 3635

Filed: February 17, 2004

Examiner: --

For: HOLLOW SECTION AND A PROCESS FOR ITS MANUFACTURE

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Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**INFORMATION DISCLOSURE STATEMENT**

S I R:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO 1449. A copy of each of the listed foreign documents is also enclosed.

The present Information Disclosure Statement is being submitted prior to issuance of a first Office Action on the merits in the present application.

The present invention defines a hollow section and a process for its manufacture which is not believed to be disclosed by the enclosed references.

Each of the cited foreign references is accompanied by a U.S. equivalent or English-language Abstract.

In the event the actual fee is greater than the payment submitted or is inadvertently not enclosed or if any additional fee during the prosecution of this application is not paid, the Patent Office is authorized to charge the underpayment to Deposit Account No. 15-0700.

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on July 12, 2004:

Klaus P. Stoffel

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Name of applicant, assignee or  
Registered Representative

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Signature

July 12, 2004

\_\_\_\_\_  
Date of Signature

KPS:sks

Respectfully submitted,

\_\_\_\_\_  
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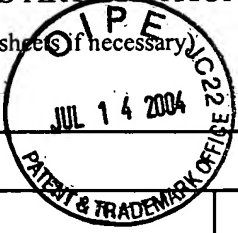
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<b>APPLICANT'S ART CITATION</b> (Use several sheets if necessary)		Application <b>10/780,334</b>		OFGS File No. <b>P/4303-34</b>	
		Applicant <b>CHITIC et al.</b>			
		Filing Date <b>February 17, 2004</b>		Group Art Unit <b>3635</b>	



U.S. PATENT DOCUMENTS						
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate
	US-6,003,930	12/1999	FRANK et al.			
	US-					
	US-					
	US-					
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FOREIGN PATENT DOCUMENTS							
	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
						Yes	No
	CH 691-731	9/2001	Switzerland (=US 6,003,930)			Abst.	
	EP 1 000 678 A2	5/2000	Europe			Abst.	
	DE 198 51 326 C1	2/2000	Germany			Abst.	
	DE 35 32 499 C1	11/1986	Germany			Abst.	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)		

Examiner	Date Considered
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.